#### **FEE TRANSMITTAL**

### Electronic Version v08

## Stylesheet Version v08.0

Title of Invention

METHOD FOR GROWING A GATE OXIDE LAYER ON A SILICON SURFACE WITH PRELIMINARY N2O ANNEAL

Application Number:

Date:

First Named Applicant: Shian-Jyh Lin
Attorney Docket Number: NTCP0014USA

# **TOTAL FEE AUTHORIZED \$810**

Patent fees are subject to annual revisions on or about October 1st of each year.

Filing as large entity

## **BASIC FILING FEE**

Fee Description	Fee Code	Amount \$	Fee Paid \$		
Utility Filing Fee	1001	770	770		
Subtotal For Basic Filing Fees: \$ 77					

## **EXTRA CLAIM FEES**

Fee Description	Extra Claim	Fee Code	Amount \$	Fee Paid \$		
Total Claims: 10	0	1202	18	0		
Independent Claims : 2	0	1201	86	0		
Subtotal For Extra Claims Fees: \$ 0						

### **ASSIGNMENT FEES**

Fee Description	Property Number	Quantity	Fee Code	Amount \$	Fee Paid \$	
Recording Each Patent	00000000	1	8021	40	40	
Assignment Per Property Fee						
Subtotal For Additional Fees: \$40						

### **AUTHORIZED BILLING INFORMATION**

The commissioner is hereby authorized to charge indicated fees and credit any overpayments to:

Deposit account number: 503105

Access Code \*\*\*\*

Deposit name: North America Intellectual Property Corporation

Deposit authorized name: /WINSTON HSU/

Signature: /VAEB-JMXX-8IIL/

Date (YYYYMMDD): 2004-08-28

Charge Assignment Fees Required Under 37 C.F.R. Section 1.21 (h).

Charge Any Additional Fee Required Under 37 C.F.R. Sections 1.16 and 1.17.